

#4/IDS
4/3/03
VB

Inventor: Garry A. Mercaldi
Title: Low Selectivity Deposition Methods
Assignee: Micron Technology, Inc.
Serial No.: 09/643,004
Filing Date: August 21, 2000


INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449, and copies of which are attached. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 20 Mar 2003

Attorney: 
James E. Lake
Reg. No. 44,854
WELLS ST. JOHN P.S.
601 W. First Ave., Suite 1300
Spokane, WA 99201-3828
(509) 624-4276

EV085426454

03/27/2003 EV0111 00000070 09643004 160.00 0P
01 FC:1806